

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination ESTKOWSKI ET AL.	
		Examiner Christine M. Behncke	Art Unit 3661	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kindel et al, Kinodynamic Motion Planning Amidst Moving Obstacles", April 2000, IEEE, Proceedings of the 2000 IEEE International Conference of Robotics & Automation, 537-543.
	V	Urmson, Approaches for Heuristically Biasing RRT Growth, October 2003, IEEE, Proceedings of the 2003 IEEE/RSJ Intl. Conference on Intelligent Robots and Systems, 1178-1183.
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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